



Appl. No. 10/099,840

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/099,840  
Confirmation No. .... 5306  
Filing Date .... March 12, 2002  
Inventor.... James J. Hofmann  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 2818  
Examiner .... Hoang, Quoc Dinh  
Attorney's Docket No. .... MI22-1803  
Customer No. .... 21567  
Title: Methods of Forming Patterns for Semiconductor Constructions; and Molds  
Configured to Patterned Masses Associated with Semiconductor Constructions

**RESPONSE TO MAY 30, 2003 OFFICE ACTION**

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**AMENDMENTS**

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